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2878

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date (if appropriate)
AA							
AB							
AC							
AD							
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AH							
AI							
AJ							

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Country	Class	Sub-Class	TRANSLATION	
							Yes	No
AK	AQ	2001-234348	08/31/2001	Japan			AB	
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

AK	AQ	SATAKE, T., "Gas Phase Analysis of MOCVD Materials by FTIR" Horiba Technical Reports, No. 22, March 2001, pp. 36
	AR	
	AS	

EXAMINER

DATE CONSIDERED

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